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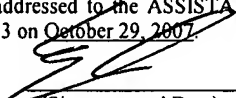
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Hoon Kim et al.
SERIAL NO.: 10/779,446 EXAMINER: Shi K. Li
DATE FILED: February 13, 2004 ART UNIT: 2613
FOR: PASSIVE OPTICAL NETWORK USING ERROR CORRECTION
CODE

CERTIFICATE OF MAILING UNDER 37 CFR §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, P.O. BOX 1450 ALEXANDRIA, VA 22313 on October 29, 2007.

Steve S. Cha, Reg. No.: 44,069
(Name of depositor)


(Signature and Date)

Mail Stop Amendment
Commissioner for Patents
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Sir:

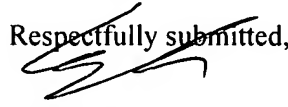
INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's and Applicant's representatives' Duty of Disclosure under 37 CFR § 1.56, and pursuant to 37 CFR §1.97(d) and MPEP 717.05(b), Applicant(s) submit herewith documentary information for consideration by the Examiner. Information herein cited is only set forth in fulfillment of Applicant's duty of candor in disclosing all information brought to his attention, and is not an admission that it can be used adversely. The publications forwarded herewith are listed on the enclosed Form PTO-1449. Applicant(s) request that the Examiner, upon reviewing the enclosed materials, initial the enclosed form and return a copy thereof in accordance with the instructions on the form.

Applicant further note that each item of information contained in the enclosed Form was first cited from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the statement.

Enclosed please find copies of 4 Foreign References listed on the attached Form PTO-1449.

Respectfully submitted,


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Date: October 29, 2007